

**Slater & Matsil, L.L.P.**

Suite 1000  
17950 Preston Road  
Dallas, Texas 75252-5793  
Phone: 972-732-1001 Facsimile: 972-732-9218

**RECEIVED  
CENTRAL FAX CENTER**

FEB 19 2004

**OFFICIAL****FACSIMILE COVER SHEET**

To Commissioner of Patents and Trademarks	Total Pages Sent: 3 (including cover sheet)
Facsimile Number: (703) 872-9306	Transmission Date: February 19, 2004

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Tews, *et al.* Docket No.: 00P9031US  
Serial No: 09/714,356 Art Unit: 2813  
Date Filed: November 16, 2000  
Title: Nitrogen Implantation Using a Shadow Effect to Control Gate Oxide  
Thickness in DRAM Semiconductor

**CERTIFICATION OF FACSIMILE TRANSMISSION**

I hereby certify that the following papers are being transmitted by facsimile to the U.S. Patent and Trademark Office at (703) 872-9306 on the date shown above:

- Facsimile Transmission Certification (1 page)
- Change of Correspondence Address (1 page)
- Associate Power of Attorney (1 page)

Respectfully submitted,

  
Julie Russell  
Legal Assistant

**Confirmation Respectfully Requested**

This facsimile is intended only for the use of the address named and contains legally privileged and/or confidential information. If you are not the intended recipient of this telecopy, you are hereby notified that any dissemination, distribution, copying or use of this communication is strictly prohibited. Applicable privileges are not waived by virtue of the document having been transmitted by Facsimile. Any misdirected facsimiles should be returned to the sender by mail at the address indicated on this cover sheet.

**BEST AVAILABLE COPY**